

**Notice of References Cited**

Application/Control No.

10/823,771

Applicant(s)/Patent Under  
Reexamination  
APOSTOLO ET AL.

Examiner

Henry S. Hu

Art Unit

1713

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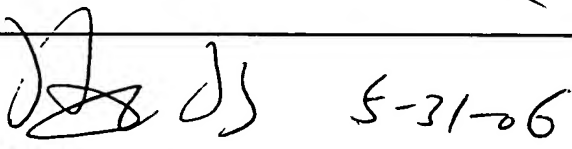
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-5,646,223	07-1997	Navarrini et al.	526/247
*	C	US-5,495,028	02-1996	Navarrini et al.	549/455
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	N	EP-633,257 A1	06-1994	EP	Navarrini et al.	----
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**NON-PATENT DOCUMENTS**

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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